



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
**Saka et al.**

Application Number: **10/029,080**

Filed: **December 21, 2001**

For: **In-Situ Method and Apparatus  
for End Point Detection in  
Chemical Mechanical Polishing**

Group Art Unit: **2877**

Examiner: **M. P. Stafira**

**PETITION FOR TWO MONTH  
EXTENSION OF TIME**

CERTIFICATE OF MAIL (37 CFR 1.8(a))  
I hereby certify that this paper (along with any referred to  
as being attached or enclosed) is being deposited with the  
United States Postal Service with sufficient postage as First  
Class Mail in an envelope addressed to: Commissioner for  
Patents, Washington, DC 20231 on September 18, 2003.

Signed: \_\_\_\_\_

Lori Cox

Commissioner for Patent  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. 1.136(a), an extension of time of:

	<u>Large Entity</u>	<u>Small Entity</u>
One Month	// \$110.00	// \$55.00
Two Months	/X/ \$410.00	// \$205.00
Three Months	// \$930.00	// \$465.00
Four Months	// \$1,450.00	// \$725.00

This Petition is hereby requested to respond to the Office Communication mailed  
April 18, 2003.

Please charge any additional fees or credit any overpayment to Deposit Account 50-  
2319 (Order No. A<sup>6</sup>9174-1/MSS/MDV (463035-29)).

Respectfully submitted,

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